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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/716,885	11/18/2003	Minoru Kumagai	03699/LH	8690
1933	7590	03/11/2009	EXAMINER	
FRISHAUF, HOLTZ, GOODMAN & CHICK, PC 220 Fifth Avenue 16TH Floor NEW YORK, NY 10001-7708			LIN, JAMES	
			ART UNIT	PAPER NUMBER
			1792	
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			03/11/2009	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Box 3(a):

The newly added limitations of "the first electrode including a plurality of first electrode sections", "a coating step of coating the surface of the flat plate", "the first electrode sections which are respectively surrounded by a plurality of partitions", and "forming the optical material layer in a region surrounded by each of the partitions" alone and/or in combination with the requirements of the dependent claims have not been considered.

Box 11:

The arguments on pg. 9-10 are directed to the newly added limitations. The arguments will be addressed upon entry of the amended claims.

Applicant argues on pg. 10-11 that Van Rijn discloses forming EL molecules by evaporation on pg. 19, lines 12-27 and by an inkjet printing method on pg. 19, lines 36-44. Applicant further argues that the present invention is different and non-obvious from Van Rijn in that respect. However, Van Rijn teaches that an alternative of forming the EL layers can be used on pg. 19, lines 31-34 where Van Rijn explicitly teaches that the EL material can be deposited using a three color micro printing method. Van Rijn describes the micro printing method on pg. 25, lines 16-31. The micro printing method is similar to that of the presently claimed invention.

Applicant argues on pg. 11 that Kiguchi and Kimura do not disclose transferring droplets provided on the flat plate onto the flat substrate. However, the arguments on directed to the newly added limitations. The arguments will be addressed upon entry of the amended claims.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jimmy Lin whose telephone number is (571)272-8902. The examiner can normally be reached on Monday thru Friday 8AM - 5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tim Meeks can be reached on 571-272-1423. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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